

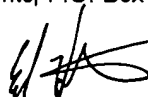
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Date: 5 May 2004

By:



Ed Hotchkiss



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: LINLIN CHEN

APPLICATION No.: 09/885,232

FILED: 20 JUNE 2001

FOR: **APPARATUS AND METHOD FOR
ELECTROLYTICALLY DEPOSITING
COPPER ON A SEMICONDUCTOR
WORKPIECE**

EXAMINER: WESLEY A. NICOLAS

ART UNIT: 1742

CONF. No: 4989

Amendment Under 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated 5 November 2003 in the above-identified application. Please amend the application as follows:

Amendments to the Specification begin on page 2.

Amendments to the Claims are reflected in the listing of claims beginning on page 3.